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PATENT 930055-2031

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## <u> THE UNITED STATES PATENT AND TRADEMARK OFFICE</u>

Appineant(s)

Tetsuo YAMADA, Kosuke NISHIMURA, Keigo NAGAO

Serial No.

10/518,704

For

THIN FILM PIEZOELECTRIC OSCILLATOR, THIN

FILM PIEZOELECTRIC DEVICE, AND MANUFACTURING METHOD THEREOF

Filing Date

December 17, 2004

Examiner

Not Yet Assigned

Group Art Unit

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745 Fifth Avenue New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 1, 2005.

Ronald R. Santucci, Reg. No. 28,988

ame of Applicant Assignee or Registered Representative

G Signature
August 1, 2005

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Date of Signature

## TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(B)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application; within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; or before the

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mailing date of a first Office Action on the merits, whichever event occurs last. No fee is required.

The Commissioner is authorized to charge any additional fee that may be required to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP

By:

Ronald R. Santucci Reg. No. 28,988 (212) 588-0800

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.